

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: To be assigned
Examiner: Sharon Brooks

In Re PATENT APPLICATION Of:

Applicant(s): Hiroomi TSUTAE)

Serial No.: 10/657,207)

Filed: September 9, 2003)

For: Process of cleaning a semiconductor
manufacturing system and method of
manufacturing a semiconductor device)

Attorney Ref: FUJI 136)

STATUS REQUEST

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:


Please let us know the status of the above-identified application and when an
Action may be expected. If the response to this status request is made by telephone, please
as for Tonya Harris (Docket Clerk) at extension 518.

Respectfully submitted,

August 11, 2005

Date

SMR:ss


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